

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DEMARK OFFICE

Attorney Docket No. 259/01/19/52

In re patent application of

Gu-Sung KIM, et al.

Group Art Unit: 2823

Serial No. 10/073,173

Examiner: Long Pham

Filed: February 13, 2002

For: WAFER LEVEL PACKAGE WITH AIR PADS AND MANUFACTURING METHOD

THEREOF

RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

Hon. Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action dated May 9, 2002, applicant hereby elects the claims of Group II, claims 1-8, for prosecution in the subject application.

Applicants, of course, reserve the right to file a divisional application covering the subject matter of the non-elected claims.

In response to the requirement for corrected drawings applicants attach hereto a corrected figure 2b.

IN THE SPECIFICATION:

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